

Lecture 10: Bulk Micromachining II

- Announcements:
- HW#3: due Tuesday, 3/5 at 9 a.m.
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- Today:
- Reading: Senturia Chpt. 3, Jaeger Chpt. 11,
Handouts: "Bulk Micromachining of Silicon"
- Lecture Topics:
 - ↔ Bulk Micromachining
 - ↔ Anisotropic Etching of Silicon
 - ↔ Boron-Doped Etch Stop
 - ↔ Electrochemical Etch Stop
 - ↔ Isotropic Etching of Silicon
 - ↔ Deep Reactive Ion Etching (DRIE)
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- Last Time:
- Just starting into Module 6
- Now, continue with this

